

Si ₃ N ₄	
Sn0 ₂	
NiCrO _X	
Ag	
NiCrO _X	
Si _x N _y	
SnO ₂	
NiCrOx	
Ag	
NiCrO _x	
Si _x N _y	
TiO ₂	
Glass Substrate	
	Sn0 2 NiCrO _x Ag NiCrO _x Si _x Ny Sn0 2 NiCrO _x Ag NiCrO _x Ag NiCrO _x

FIG. 1



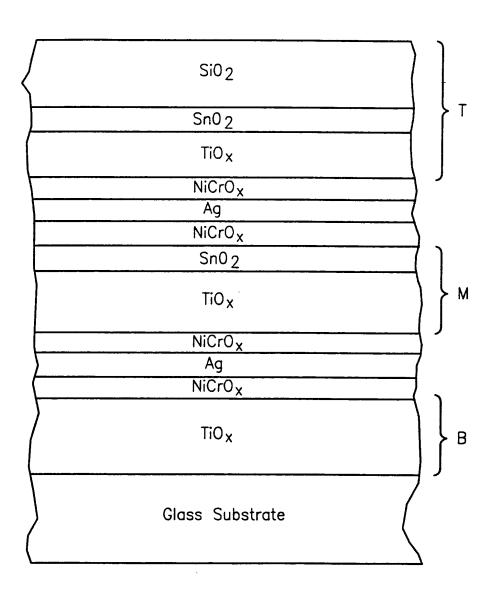
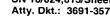


FIG. 2





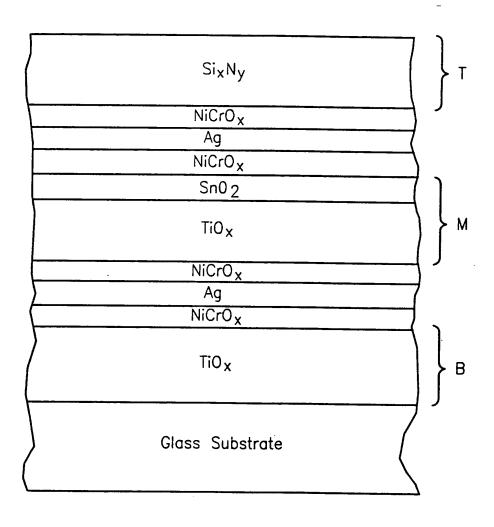


FIG. 3



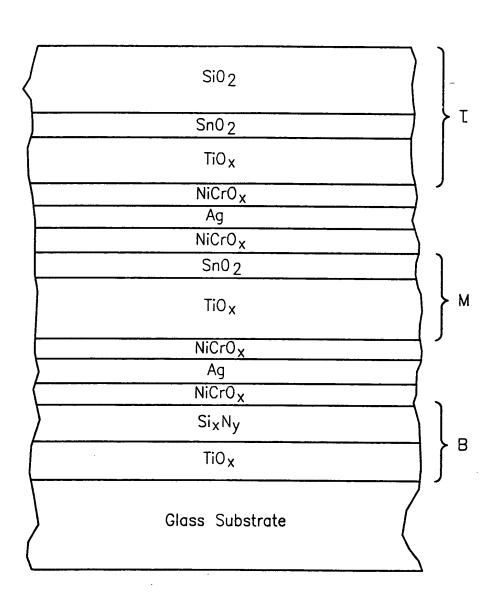


FIG. 4



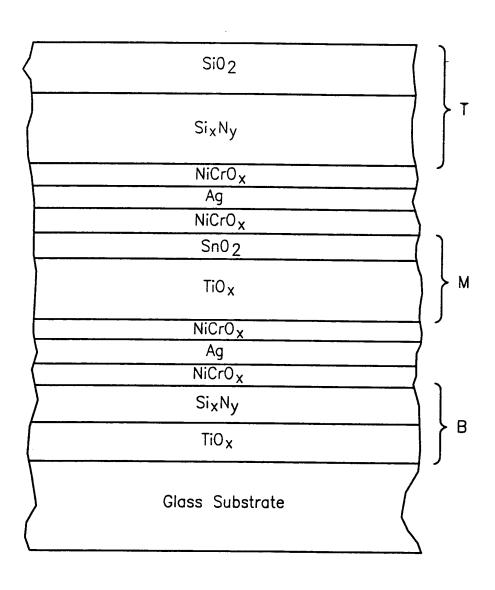


FIG. 5



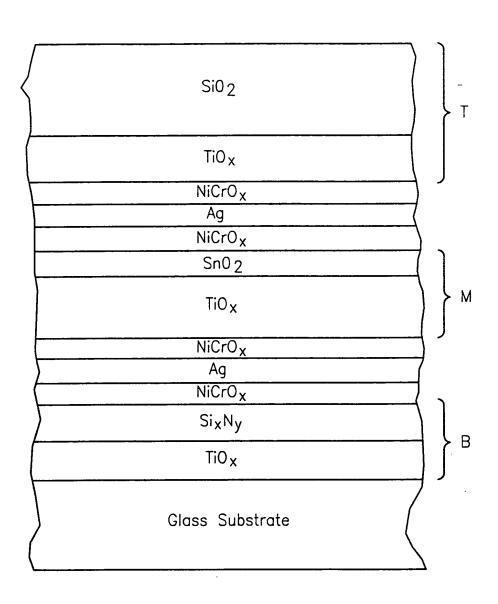


FIG. 6



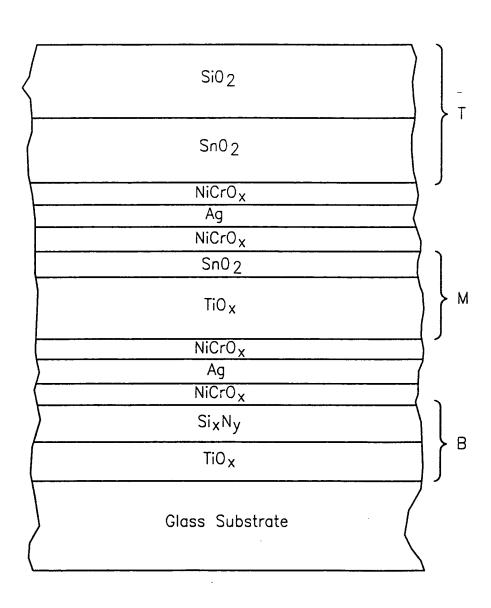


FIG. 7



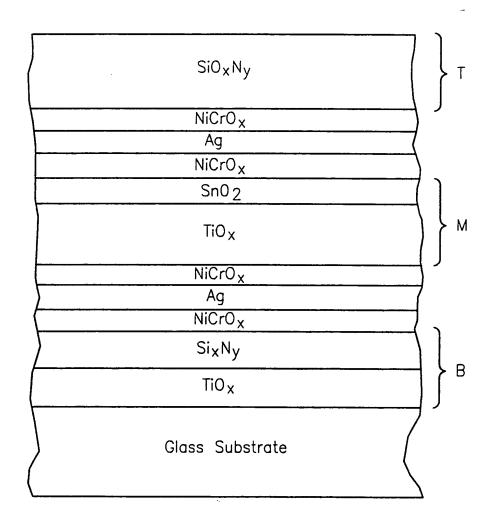


FIG. 8



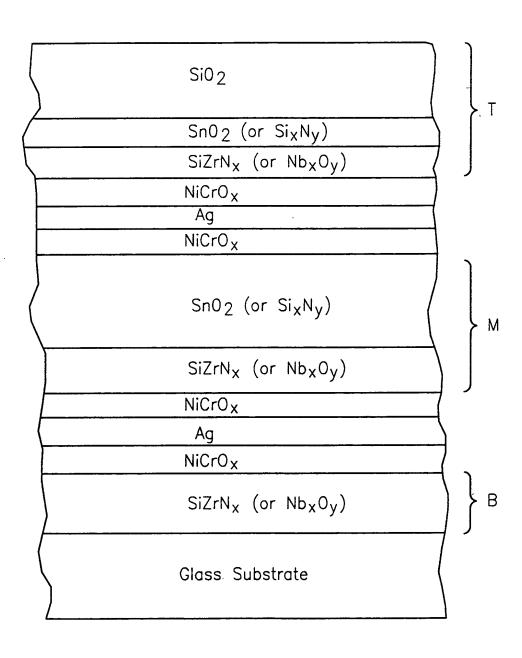


FIG. 9

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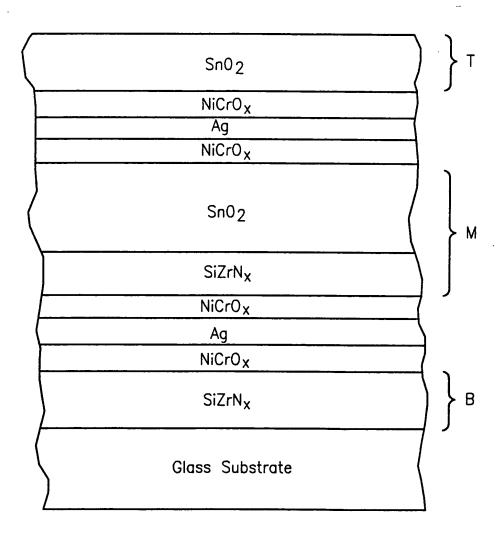


FIG. 10



	Si _x N _y) } T
	NiCrO _X	
	Ag	
	NiCrO _X	
	Si _x N _y	} M
•	SiZrN _X	\setminus
	NiCrO _X	7
{	Ag	7
	NiCrO _X	7.
	SiZrN _x	$\bigg]\bigg\}B$
(Glass Substrate	

FIG. 11



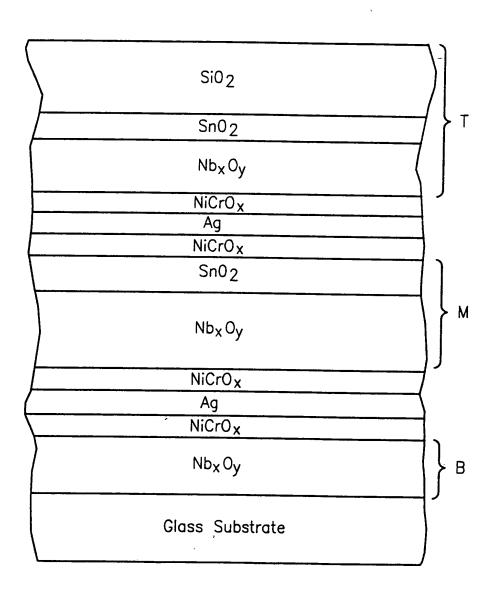


FIG. 12



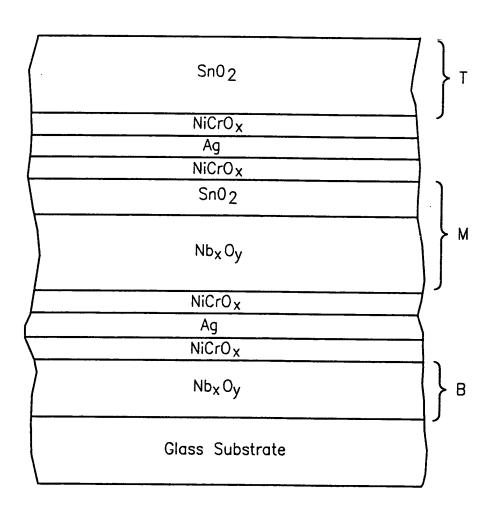


FIG. 13



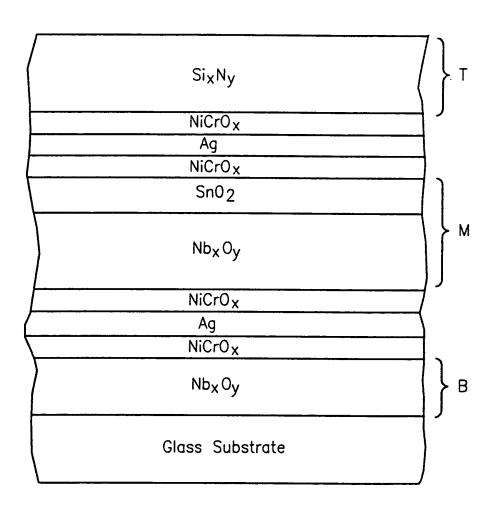


FIG. 14



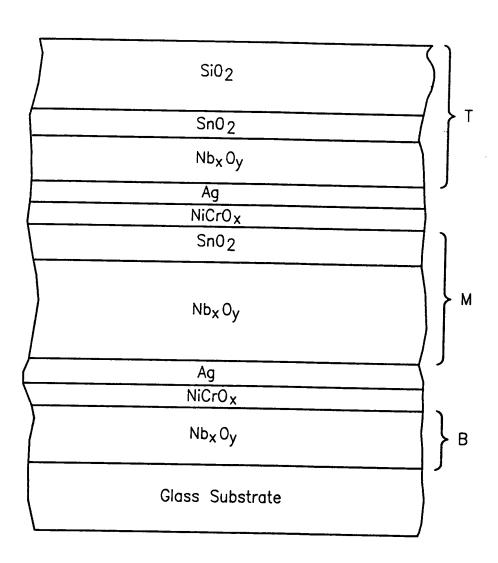
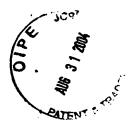


FIG. 15



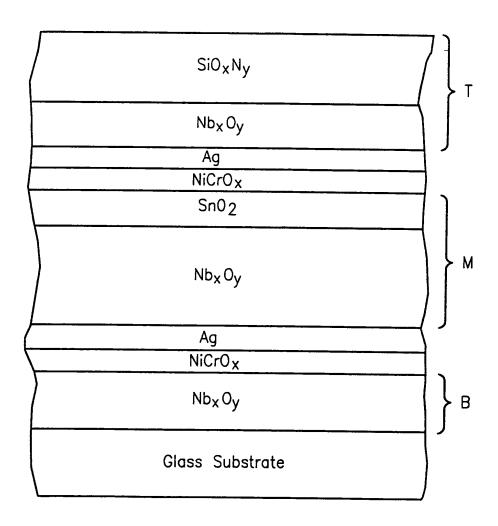


FIG. 16



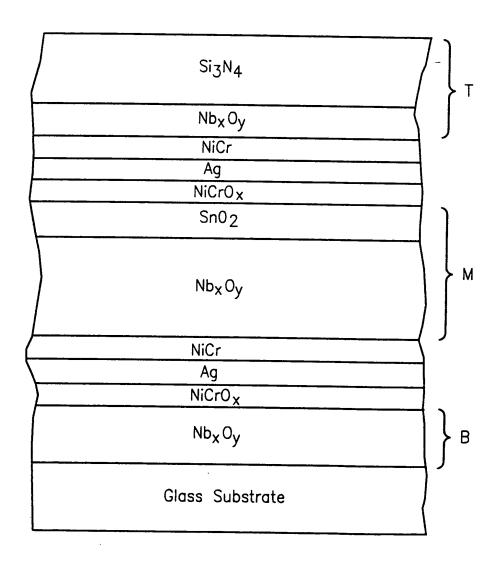


FIG. 17